

# Daniel Staaks

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/2625456/publications.pdf>

Version: 2024-02-01

5  
papers

68  
citations

1937685

4  
h-index

2053705

5  
g-index

5  
all docs

5  
docs citations

5  
times ranked

128  
citing authors

#	ARTICLE	IF	CITATIONS
1	Pattern-generation and pattern-transfer for single-digit nano devices. Journal of Vacuum Science and Technology B:Nanotechnology and Microelectronics, 2016, 34, .	1.2	34
2	Atomic layer deposition for spacer defined double patterning of sub-10 nm titanium dioxide features. Nanotechnology, 2018, 29, 405302.	2.6	19
3	Low temperature dry etching of chromium towards control at sub-5 nm dimensions. Nanotechnology, 2016, 27, 415302.	2.6	8
4	Temperature and oxygen concentration effects on anisotropy in chromium hard mask etching for nanoscale fabrication. Journal of Vacuum Science and Technology A: Vacuum, Surfaces and Films, 2019, 37, .	2.1	6
5	Polymer-metal coating for high contrast SEM cross sections at the deep nanoscale. Nanoscale, 2018, 10, 22884-22895.	5.6	1